INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 4, 2026

IGI Report Number	LG824607976
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MIXED CUT
Measurements	8.42 X 5.90 X 3.86 MM

GRADING RESULTS

Carat Weight	1.91 CARAT
Color Grade	D
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

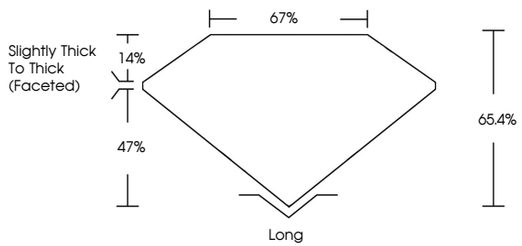
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG824607976

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG824607976

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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PROPORTIONS

67% Slightly Thick To Thick (Faceted) 14% 47% 65.4% Long

ADDITIONAL GRADING INFORMATION

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Clarity Grade VVS 2
Depth 65.4%
Table 67%
Girdle Slightly Thick To Thick (Faceted)
Culet Long
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Symmetry EXCELLENT
Fluorescence NONE
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